

Tsoo-240



Application no. 09/769,812

CB

May 3, 2004

TO: Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

FROM: George O. Saile, Reg. No. 19,572  
28 Davis Avenue  
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SUBJECT: Serial #: 09/769,812  
File Date: 1/26/01  
Inventor: Li-Te Lin, Li-Chih Chao, Chia-Shiung Tsai  
Examiner: Lan Vinh  
Art Unit: 1765  
Title: An Organic Low K Dielectric Etch With NH3 Chemistry  
Customer Number 28112

#### AMENDMENT AFTER ALLOWANCE

This is in response to the Office Action dated 4/23/04. Please amend the above-identified application for patent as follows:

#### CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner of Patents and Trademarks, Washington, D.C. 20231 on May 4, 2004.

Signature S.B.A.  
Stephen B. Ackerman, Reg. No. 37,761

Date: 5/4/04

**Amendments to the Specification** begin on page 3 of this paper.

**Remarks/Arguments** begin on page 4 of this paper.